

Automated Multi-Meter Method for the Scaling of Low AC Voltage from 200 mV to 2 mV

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Received January 4, 2013; revised February 10, 2013; accepted February 20, 2013

ABSTRACT

A set of seven single junction thermal converter Micropotentiometers (μ Pots) has been constructed at the National Institute for Standards (NIS), Egypt. This set has been built to cover the low *ac* voltage ranges from 2 mV to 200 mV at frequencies from 40 Hz up to 20 kHz. The construction of the μ Pots set has been presented and an adopted calibration method has been performed as well. This method has been performed by means of a step-down procedure using a Digital Multi-Meter (DMM). The scaling procedures have been carried out in sequential steps starting from the calibration of the 200 mV- μ pot by using DMM that is accurately calibrated at its 200 mV *ac* voltage range down to 2 mV- μ Pot. Furthermore, a new automatic calibration system has been established to achieve the scaling procedures. This system has been specially designed using Laboratory Virtual Instrument Engineering Workbench (LabVIEW) software to overcome the deficiencies of manual methods. The automatic calibration has been investigated of all μ Pots at different frequencies. The *ac-dc* differences for the μ Pots and their uncertainty evaluation from 2 mV to 200 mV at different frequencies from 40 Hz to 20 kHz have been determined.

Keywords: Micropotentiometer; Low *ac* Voltage Calibration; *ac-dc* Difference; Digital Multimeter; Step Down Procedure

1. Introduction

The electrical SI units are defined and realized as *dc* electrical quantities. *ac* electrical quantities can't be directly determined in terms of SI units, so *ac* quantities have been determined in terms of the *dc* quantities. In order to determine *ac* quantities, it is necessary to transfer *ac* to *dc* [1]. The *ac-dc* transfer standards are maintained by the National Metrology Institutes (NMIs) to provide a primary link between the active *ac* and *dc* quantities [2]. Device testing and characterization for today's very small and power efficient electronics requires sourcing low *ac* voltage levels (microvolt and millivolt) which demands the use of precision low *ac* voltage sources. A device fulfilling this need is called radio frequency μ Pot. The μ pot is a very precision standard for determining a low output *ac* voltage over a wide range of frequencies. It is the most stable, accurate, and reliable standard in the millivolt (mV) region as low impedance sources of known radio frequency (RF) voltage [3]. Therefore, the traceability of *ac* voltage in the mV ranges has been established using μ Pots which can be used as *ac* reference transfer standards [4]. The μ Pot is used as thermal transfer devices that contain thermal converter (TC) and output radial resistor to obtain accurate AC voltages in the mV

ranges. The thermal converters are widely used in the field of *ac-dc* transfer standards [2]. There are different types of μ Pots according to the thermal converter used in its construction such as single junction thermal converter (SJTC) and thin film multi junction thermal converter (MJTC). Although MJTC in planar technique are used for voltages down to 100 mV [5] and integrated μ Pots are designed in the same thin film technology [4], SJTC are widely used for *ac-dc* transfer because of their simple construction and ready availability [6]. This paper is dealing with a construction as well as an adopted automatic calibration method of a precise SJTC μ Pots set. This μ Pots set is implemented as a part of upgrading the *ac* capabilities at NIS. It has been entirely built to cover the ranges from 2 mV to 200 mV at frequencies from 40 Hz and up to 20 kHz. Nevertheless, in metrological and Industrial laboratories, programmable instruments are now widely employed and increasingly included in measurement systems, because they can perform automatically the time consuming operations required in the calibration activity. Actually, the available commercial software is not suitable for the metrological laboratories which work at high level of accuracy and precision. Accordingly, there is an effective request for software able to calibrate such instruments [7]. For this reason, a special program-

mable calibration system has been built using the labVIEW. To achieve low *ac* voltage traceability at NIS, an automated DMM method has been performed for the scaling of *ac* voltage from 200 mV to 2 mV by means of a step-down procedure. The calibration results of all the μ Pots and their associated uncertainties are fully investigated as well.

2. Micropotentiometer Construction

The constructed set consists of seven SJTC μ Pots having output *ac* voltage with nominal values of 2, 5, 10, 20, 50, 100 and 200 mV. Each μ Pot consists of an ultra high frequency (UHF) single junction thermalelement in series with a low inductance radial output resistor. In the SJTC energy dissipated by an *ac* current flowing through a heater resistor, raising its temperature above the ambient is compared to the energy dissipated by a *dc* current flowing through the same heater. The increase in the temperature of the heater at *ac* and *dc*, proportional to the dissipated energy, is measured using a thermocouple. A relative difference between the response of the converter to *ac* and *dc* inputs, called *ac-dc* transfer difference, is determined from these two measurements. The SJTC which is used in each of our adopted μ Pots construction has been tested at NIS. It shows innovative design and produces extremely low transfer error [8]. The main technical specifications of it are 5 mA nominal heater current and 90 Ω heater resistance [9].

The second main component in constructing each μ Pot is the radial resistor. It consists of ten equal resistors ensured an optimum frequency response, as it is a special design annular shape film resistor. These ten resistors are connected in parallel and placed between the center pin and the outer flange of an N-type female connector. It is securely soldered into the output N-type coaxial connector and screwed into the μ Pot case [10].

Figure 1 shows μ Pot schematic diagram. The radial resistors with nominal values of 0.4 Ω to 40 Ω are combined with the 5 mA SJTC in order to obtain output voltage ranges from 2 mV up to 200 mV respectively. The output voltage is nominally the product of the heater current and the resistance of the radial resistor.

Table 1 indicates the nominal values of equivalent radial resistors for each μ Pot output voltage.

3. Step-Down Scaling of Measurements

Step-down scaling of the *ac* voltages from 200 mV to 2 mV is shown in **Figure 2**. The process starts with the NIS *ac-dc* transfer primary standard which is 300 mV Thin Film MJTC calibrated at PTB, Germany. This standard is used to calibrate a Fluke 8508 A Digital multimeter (DMM) at range 200 mV. The calibrated DMM is then used to calibrate the 200 mV- μ Pot. The μ pots are

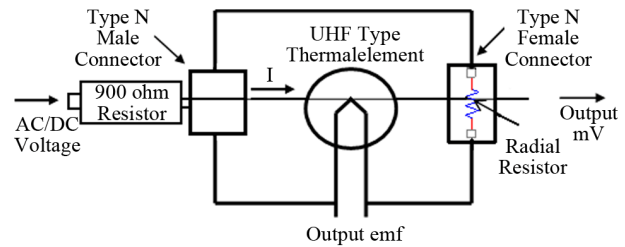


Figure 1. Schematic diagram of the μ Pot.

Table 1. Radial resistor nominal value for each μ Pot range.

μ Pot Range (mV)	Radial Resistor Nominal Value (Ω)
200	40
100	20
50	10
20	4
10	2
5	1
2	0.4

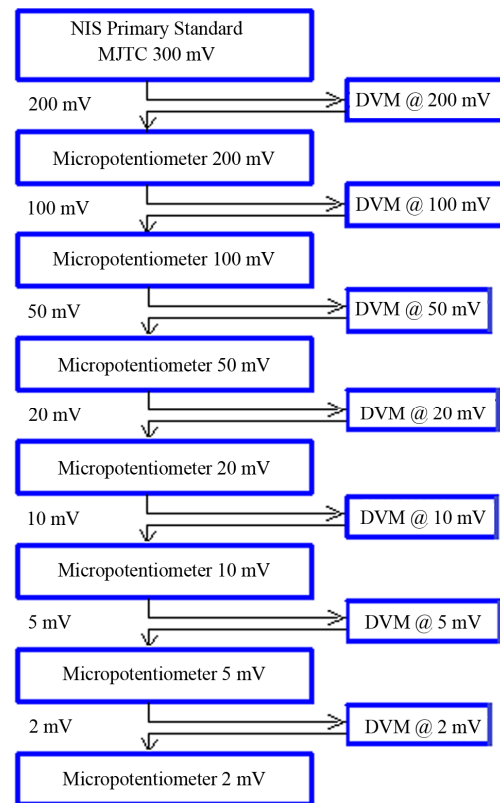


Figure 2. Step-down scaling of the *ac* voltages.

used from full to half of their nominal voltages with almost the same *ac-dc* differences [11]. Consequently, the calibrated 200 mV- μ Pot is used to calibrate the DMM at 100 mV level. The DMM is then used to calibrate the 100 mV- μ Pot. The process is continued until all the lower ranges of the μ Pots down to 2 mV are calibrated.

4. Procedures

The scaling procedures have been automatically performed through implementation of an automated calibration system. This automated system accelerates the measurement procedures, eliminates the operator’s errors, and significantly improves the measurement process. Moreover, it allows statistical proceeding of the results in rather short time. General Purpose Interface Bus (GPIB) card and cables are used to communicate and control the automated system hardware with its software. The new software LabVIEW program is designed to perform the following: control the calibrator output, perform measurement procedures with the specified times for the warming-up and the steady-state of the TE, collect measurements data indicated by DMM, and generate data sheets at the end for saving the measurement results. The scaling procedures from 200 mV to 2 mV are carried out in several sequential steps.

The first step of the scaling procedures is the calibration of Fluke 8508 A DMM at a 200 mV *ac* voltage range using the 300 mV thin-film MJTC. This automated calibration system consists of a highly accurate programmable calibrator (Fluke 5720 A) to precisely source both alternating and direct voltages, highly sensitive, 8.5 digits, DMM (Fluke 8508 A), 8.5 digits, DMM (HP 3458 A) to measure the μ Pot output emfs and 300 mV thin film MJTC.

The multifunction calibrator, which is the alternating and the direct voltages source is connected using a tee-connector to both the thin film MJTC and the Fluke 8508 A DMM which is recently calibrated at its *dc* voltage mode. **Figure 3** illustrates the Set-up of this calibration step.

Alternating voltage in addition to direct voltage in positive and negative polarities is sequentially applied in the sequence (dc^+ , dc^- , *ac*) from the calibrator. Enough time is allowed during the automated program adjustment to warm up the TE. Also, it is important to wait a frequently predicted time before recording the DMM output electro motive forces (emfs) indicated by HP 3458 A DMM until the MJTC reached its steady-state. This sequence is repeated for ten times. The corresponding MJTC output emfs readings have been automatically recorded from the 3458 A DMM in specially prepared

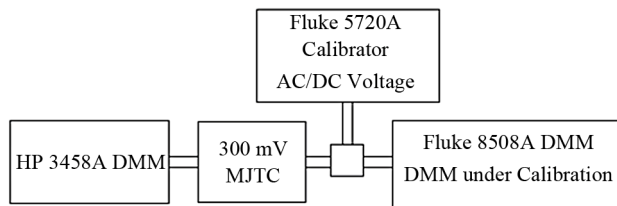


Figure 3. Circuit set-up for DMM calibration at 200 mV by MJTC.

excel sheet. Furthermore, the 8508 A DMM readings are recorded in the same excel sheet. The difference between the MJTC responses due to the applied *dc* average voltage and the *ac* voltage (δ_{diff}) is calculated using the equation:

$$\delta_{diff} = \frac{E_{ac} - E_{dc}}{nE_{dc}} \tag{1}$$

Where,

E_{ac} : output emf for the AC input voltage.

E_{dc} : mean emfs values for forward (dc^+) and reverse (dc^-) voltages.

n : response characteristic varies between 1.6 and 2, depending on the amplitude of the input signal [12]. The factor n is automatically determined for the MJTC and all the μ Pots individually. The procedures of the factor n determination and the automatic program are fully described in [13].

The accurate applied value at 200 mV *ac* voltage, V_{ac} , is calculated from:

$$V_{ac} = \frac{V_{dc^+} + V_{dc^-}}{2} (1 + \delta_{MJTC} + \delta_{diff}) \tag{2}$$

Where,

δ_{MJTC} : *ac-dc* transfer difference of the MJTC.

δ_{diff} : difference between the MJTC responses due to the *dc* average voltage and the *ac* voltage.

V_{dc^+} , V_{dc^-} : the accurate applied *dc* voltages 8508 A DMM readings and the accurate applied value obtained from equation 2 is then used to obtain the 8508 A DMM correction at its 200 mV *ac* voltage in order to get its accurate calibrated value.

The second step is the calibration of the 200 mV- μ Pot using the Fluke 8508 A DMM which is calibrated from the previous step in its 200 mV *ac* voltage range. This automated calibration system consists of 5720 A calibrator, 8508 A DMM, 3458 A DMM to measure the μ Pot output emfs, 200 mV- μ Pot and 900 Ω resistor.

In order to perform this step, the calibrator is connected to the 200 mV- μ Pot through a 900 Ω series resistor to pass 5 mA to the μ Pot. 3458 A DMM is connected to measure the μ Pot output emf readings. **Figure 4** demonstrates the set-up of the second calibration step. The μ Pot output emfs and the 8508 A DMM readings are recorded in another excel sheet.

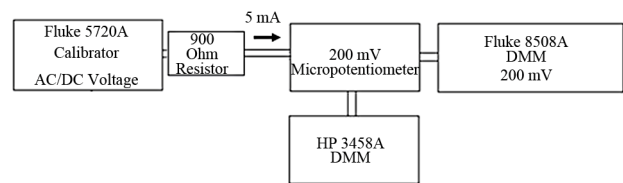


Figure 4. Circuit set-up for 200 mV- μ Pot calibration.

The 200 mV- μ Pot *ac-dc* difference (δ) is determined from the following equation:

$$\delta = \frac{V_{ac}^* - \frac{V_{dc^+} + V_{dc^-}}{2}}{\frac{V_{dc^+} + V_{dc^-}}{2}} - \delta_{diff} \quad (3)$$

Where,

V_{ac}^* : calibrated 200 mV *ac* voltage of 8508 A DMM after putting its correction obtained from the previous step.

V_{dc^+} , V_{dc^-} : calibrated 200 mV *dc* voltages of 8508 A DMM.

δ_{diff} : difference between the 200 mV- μ Pot responses.

In the third step, the calibrated 200 mV- μ Pot is used to calibrate the Fluke 8508 A DMM at its *ac* 100 mV range. The automated calibration system consists of 5720 A calibrator, 8508 A DMM, 3458 A DMM, 200 mV- μ Pot and 900 Ω resistor. As shown in **Figure 5**, the calibrator is connected to the 200 mV- μ Pot through a 900 Ω series resistor to pass 2.5 mA to the μ Pot to obtain 100 mV output voltage. The μ Pot output e.m.fs and the 8508 A DMM readings are recorded in excel sheet.

The 8508 A DMM correction at its 100 mV *ac* voltage is then obtained from the 8508 A DMM recorded readings and from:

$$V_{ac} = \frac{V_{dc^+} + V_{dc^-}}{2} (1 + \delta_{\mu Pot} + \delta_{diff}) \quad (4)$$

Where,

V_{ac} : the accurate calibrated *ac* voltage applied on the 8508 A DMM.

$\delta_{\mu Pot}$: *ac-dc* transfer difference of the 200 mV- μ Pot.

The calibrated 100 mV range DMM is used for the calibration of 100 mV- μ Pot. Then, the calibrated 100 mV- μ Pot is used to calibrate the DMM at 50 mV range and so on till reaching to the calibration of the 2 mV- μ Pot by

using the automated calibration systems described in the second and third steps.

5. Experimental Results

The values of the n-factor test of our μ Pot set are within (1.76 to 1.91). These values of n-factor are very acceptable [5]. The *ac-dc* differences for the μ Pots from 2 mV to 200 mV at different frequencies from 40 Hz to 20 kHz are also determined. All components of the combined standard uncertainty (Type A and Type B) are taken into consideration. The combined uncertainty equals to the Root Sum Square (RSS), of all the uncertainty contributions. The expanded uncertainty is obtained by multiplying the combined uncertainty by coverage factor " k ". The value of coverage factor gives the confidence level for the expanded uncertainty. Most commonly, we scale the overall uncertainty by using the coverage factor $k = 2$, to give a level of confidence of approximately 95% according to the ISO GUM [14,15]. **Table 2** illustrates the uncertainty budget for the 100 mV- μ Pot at 40 Hz as an example.

Generally, the considered expanded uncertainty is a round approximation of the calculated uncertainty. For example, the considered expanded uncertainty for the 100 mV- μ Pot at 40 Hz becomes 30 ppm. **Table 3** shows the *ac-dc* differences (δ) and the expanded uncertainties (U_{exp}) of all the calibrated μ Pots from 200 mV to 2 mV at the specified frequencies 40 Hz, 1 kHz, 10 kHz and 20 kHz.

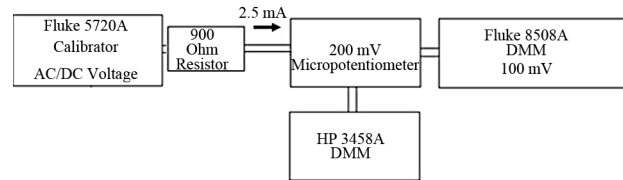


Figure 5. Circuit set-up for DMM calibration at 100 mV by the calibrated 200 mV- μ Pot.

Table 2. Uncertainty budget for 100 mV μ Pot at 40 Hz.

Uncertainty Sources	Standard Uncertainty	Probability Distribution	Divider	C_i	Uncertainty Contribution, ppm
Repeatability of V_{ac}	0.83 μ V	Normal	1	10	8.3
Resolution of 8508A DMM	0.29 nV	Rectangular	$\sqrt{3}$	10E4	2.9E-03
200 mV μ Pot Calibration	13.8 ppm	Normal	2	1	6.9
Repeatability of δ	3.7 ppm	Normal	1	1	3.7
Combined standard uncertainty:					± 11.4 ppm
Effective degrees of freedom:					∞
Expanded Uncertainty at confidence level 95%, ($k = 2$):					± 22.8 ppm

Table 3. δ and expanded uncertainties of all μ Pot at different frequencies.

μ Pot Range	Frequency							
	40 Hz		1 kHz		10 kHz		20 kHz	
	δ , ppm	U_{exp} , \pm ppm	δ , ppm	U_{exp} , \pm ppm	δ , ppm	U_{exp} , \pm ppm	δ , ppm	U_{exp} , \pm ppm
200 mV	7.2	15	7.8	50	31	10	150	15
100 mV	37	30	14	50	48	10	95	30
50 mV	12	30	12	40	15	20	14	40
20 mV	8.2	30	7.1	40	32	25	60	40
10 mV	3.1	90	7.1	40	32	25	31	75
5 mV	34	100	29	70	6.4	80	26	75
2 mV	21	115	29	70	72	85	11	80

It is found that the *ac-dc* differences of the 200 mV to 2 mV μ Pots are from 3.1 ppm to 150 ppm at the different frequencies from 40 Hz up to 20 kHz. μ Pots can be used to generate *ac* voltage signals in millivolt ranges with *ac-dc* differences ranging from 20 ppm to 1000 ppm [3]. Thus, it is shown that *ac-dc* differences of our μ Pots are acceptable where their values are much smaller than the higher limit of the admitted *ac-dc* differences.

6. Conclusion

The established single junction thermal converter μ Pots set provides a reference standard *ac* voltage source in the millivolt region. It offers stable output *ac* voltage ranges from 2 mV up to 200 mV at frequencies range from 40 Hz to 20 kHz. To achieve low *ac* voltage traceability at NIS, an automated DMM method has been performed for the scaling of *ac* voltage from 200 mV to 2 mV by means of a step-down procedure. The LabVIEW program which is constructed to automatically calibrate the μ Pots significantly improves the measurement process as well as it allows statistical proceeding of the results in rather short time. The *ac-dc* differences for the μ Pots at different frequencies from 40 Hz to 20 kHz are determined. It is clearly shown that the *ac-dc* differences of the μ Pots are within reasonable and acceptable ranges. The expanded uncertainty of the calibrated μ Pots is also evaluated with 95 % confidence level at these frequencies.

7. Acknowledgements

The authors thank Dr. Umberto Pogliano for his guidance and advices.

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